

Application/Control No.	Applicant(s)/Patent under Reexamination
10/644,931	JEON, CHEOL-MIN
Examiner	Art Unit
Ramnandan Singh	2614

SEARCHED							
Class	Subclass	Date	Examiner				
UPPA	IFD H	1931 or	R				
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INTERFERENCE SEARCHED					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
EAST (Search strategy enclosed)	10/31/2006	Rs			
					